



**ELECTRONIC COPY**

LG711511872  
Report verification at igi.org



May 27, 2025

IGI Report Number **LG711511872**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PENTAGON STEP CUT**

Measurements **9.11 X 5.44 X 3.31 MM**

**GRADING RESULTS**

Carat Weight **1.13 CARAT**

Color Grade **D**

Clarity Grade **VS 1**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

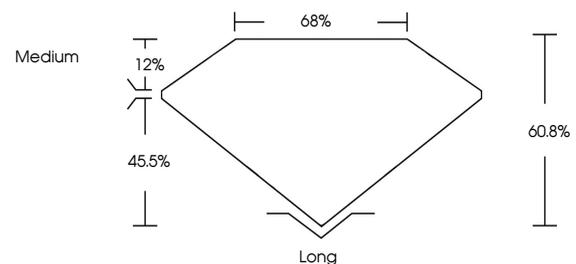
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG711511872**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



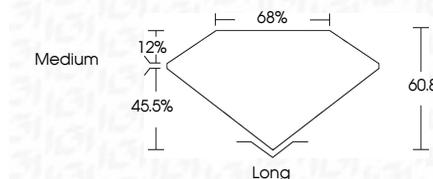
Sample Image Used

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

| IF                  | WS <sup>1-2</sup>           | VS <sup>1-2</sup>      | SI <sup>1-2</sup> | I <sup>1-3</sup> |
|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included         |



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**IGI**



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**PENTAGON STEP CUT**  
9.11 X 5.44 X 3.31 MM  
Carat Weight **1.13 CARAT**  
Color Grade **D**  
Clarity Grade **VS 1**  
Depth **60.8%**  
Table **45.5%**  
Girdle **Medium**  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG711511872**

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